

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	Group Art Unit: Unknown
Shen, et al	Examiner: Unknown
Serial No.: 09/507,629	Attorney Docket No. 1945.P3/SILICON
Filed: 2/18/2000	
For: SELF-CLEANING PROCESS FOR ETCHING SILICON-CONTAINING MATERIAL	December 7, 2000 San Francisco, California

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SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, D.C. 20231

Sir/Madam:

Attached hereto are PTO-1449 forms listing documents believed relevant to the subject application. It is respectfully requested that these documents be considered by the Examiner and initialed copies of the forms be returned to the undersigned.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to

Commissioner for Patents
Washington D C 20231

By Rowena Montoya Dated

Under 37 C F R § 1.97(b) (3), an Information Disclosure Statement shall be considered by the Office if filed before the mailing date of the first office action.

Therefore, it is believed that no fee is due for the filing of this Information Disclosure Statement. However, if any fee is due, the Commissioner is hereby authorized to charge payment of any such fees to Deposit Account No. 10-0258.

Also, if any Petition is required for the filing of this Information Disclosure Statement, such Petition is requested herein.

It should be noted that the word "prior" has been deleted from the form.

A copy of each document is enclosed.

Some of the documents may have markings thereon. No significance is meant to be attached to the markings.


With regard to any translations which may be provided herewith, the undersigned does not know how and who made the translations. Therefore, no representation is being made as to the accuracy of any translation.

These documents are not necessarily analogous.

Respectfully submitted.

JANAH & ASSOCIATES
A PROFESSIONAL CORPORATION

Date: 12/29/02

By: 
Ashok K. Janah
Reg. No. 37,487

Please continue to send all correspondence to:

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